The MAILING DATE of this communication appear claims being allowable, PROSECUTION ON THE MERITS IS (rewith (or previously mailed), a Notice of Allowance (PTOL-85) or	Application No. 10/696,588 Examiner Ha T. Nguyen	Applicant(s) ORYOJI, MICHIO Art Unit	
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OTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is so	this application. If not included nication will be mailed in due course. TH	
☐ This communication is responsive to RCE filed 1-27-6.			
☑ The allowed claim(s) is/are <u>1-21</u> .			
Acknowledgment is made of a claim for foreign priority und a) ☐ All b) ☐ Some* c) ☐ None of the:	• ,,,,,	or (f).	
1. Certified copies of the priority documents have			
2. Certified copies of the priority documents have	• •		
3. Copies of the certified copies of the priority doc	uments have been received	in this national stage application from the	те
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" on the delow. Failure to timely comply will result in ABANDONMER THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements	i
A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which gives			:
CORRECTED DRAWINGS (as "replacement sheets") must	t be submitted.		
(a) \square including changes required by the Notice of Draftsperso	on's Patent Drawing Review	(PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or	in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1.1 each sheet. Replacement sheet(s) should be labeled as such in the			
☐ DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F			
		HA NGUYEN PRIMARY EXAMINE	
tachment(s)	_		
☐ Notice of References Cited (PTO-892)		formal Patent Application (PTO-152)	
□ Notice of Draftperson's Patent Drawing Review (PTO-948)	Paper No./	ummary (PTO-413), Mail Date	
Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date		Amendment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's	Statement of Reasons for Allowance	
5. Diological Material	9. 🔲 Other		

Reasons for Allowance

Claims 1-21 are allowed.

Claims 1, 17, and 21 recite "forming a trench in the second insulating film by etching the hard mask and the second insulating film, using a resist mask in which an opening for exposing the embedded material is formed, the whole of a bottom surface of the trench being above an upper surface of the etching stopper film and below that of the embedded material".

These features in combination with the other elements of the claim are neither disclosed nor suggested by the prior art of record.

Claims 2-16 and 18-20 variously depend from claims 1 or 17, they are allowed for the same reason.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ha T. Nguyen whose telephone number is (571) 272-1678. The examiner can normally be reached on Monday-Friday from 8:30AM to 6:00PM, except the first Friday of each bi-week. The telephone number for Wednesday is (703) 560-0528.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael S. Lebentritt, can be reached on (571) 272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

HN

04-16-06

mo

Ha Nguyen

Primary Examiner